OIPE JUN 11 2007 U.S. PATENT & TRADEMARK OFFICE

FORM PTO-1449	Docket Number (Optional): JETS-02	Application Number: 10/688,333
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Applicant: Uri Cohen	Examiner: Wilkins III, Harry D.
	Filing Date: 10/17/2003	Group Art Unit: 1742

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO

NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/HW/		"Silicon Epitaxial Growth by Electrodeposition from Molten Fluorides" by U. Cohen et al., in Journal of The Electrochemical Society, Vol. 123(3), pp. 381-383, March 1976.

EXAMINER /Harry Wilkins/	DATE CONSIDERED 09/04/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.